



IN THE US PATENT AND TRADEMARK OFFICE

In Re Application of:

Marc Aho et al.

Art Unit: 3652

Serial No: 10/723,298

Examiner: Adams, Gregory W.

Filed: 11/25/2003

Confirmation number: 8822

Docket number: NAK-128

For: Compact Wafer Handling System with Single Axis Robotic Arm
and Prealigner-Cassette Elevator.

I hereby certify that this correspondence is being deposited with the United States Postal
Service as first class mail in an envelope addressed to: Commissioner for Patents,
Alexandria VA, 22313-1450 on

Sylvia Lee

Signature

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Commissioner for Patents

PO Box 1450, Alexandria VA 22313-1450

Sir:

Applicant replies to the Office Action mailed 10/17/2005 as
follows: